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LIST OF F	ATENTS AND PUBLICATIONS FOR	First Named Inventor: Roger L. Frick	
	PPLICANT'S INFORMATION DISCLOSURE STATEMENT	Filing Date: April 12, 2004	Group Art: 2828

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AN				

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FORM PTO-1449	Atty. Docket No.: Application No.: E252.12-0006 10/822,425		
PE CLIST OF PATENTS AND PUBLICATIONS FOR	First Named Inventor: Roger L. Frick		
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.